



RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2851

00862.022151.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Masaya OGURA et al.) Examiner: H. Nguyen
Application No.: 09/811,419) Group Art Unit: 2851
Filed: March 20, 2001)
For: EXPOSURE APPARATUS, METHOD OF) May 19, 2003
MANUFACTURING SEMICONDUCTOR : (Monday)
DEVICES AND PLANT THEREFOR)

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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MAY 21 2003

TECHNOLOGY CENTER 2800

AMENDMENT AFTER FINAL REJECTION
WITH PETITION FOR EXTENSION OF TIME

05/20/2003 MDAMTE1 00000103 09811419

01 FC:1252

410.00 0P

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated December 17, 2002, for two months from March 17, 2003, up to and including Monday, May 19, 2003. A check in the amount of \$410.00 for payment of the extension fee is enclosed. Please charge any additional fee required for the extension, or credit any overpayment, to Deposit Account 06-1205.

Void date: 05/20/2003 MDAMTE1
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Please amend the above-identified application as follows in response to the Official Action dated December 17, 2002:

INTRODUCTORY COMMENTS

This Amendment has been prepared in accordance with the Revised Format established by the U.S. Patent and Trademark Office, as permitted in the Pre-OG Notice dated February 4, 2003, and entitled "Amendments in a Revised Format Now Permitted."